Amendments to the Claims:

This listing of claims will replace all prior versions, and listings, of claims in the applications:

Listing of Claims:

What is claimed is:

- 1. (Currently Amended) An integrated circuit, comprising:
- a substrate;
- at least one area of dielectric material disposed on said substrate;
- at least one area of metal material disposed on said substrate;
- a bondpad associated with said at least one area of dielectric material and said at least one area of metal material; and
 - a circuitry for generating a negative capacitance, said circuitry comprising:
 - at least two transistors;
- at least two resistors; each resistor of said at least two resistors being coupled to each of said at least two transistors; and

a capacitor coupled to a first transistor of said at least two transistors and a

first resistor of said at least two resistors; wherein said circuitry generates

generating said negative capacitance of a value to compensate for a capacitance

associated with said bondpad, said active circuitry being coupled to said bondpad.

- 2. (Original) The integrated circuit as claimed in claim 1, wherein a value of said negative capacitance is approximately equal in magnitude to said capacitance associated with said bondpad.
 - 3. (Canceled)

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- 4. (Withdrawn) The integrated circuit as claimed in claim 3, wherein said at least two transistors are at least one of bipolar transistors, MOSFETS, and gallium arsenide pseudomorphic high-electron mobility transistors.
- 5. (Currently Amended) The integrated circuit as claimed in claim 1 [[3]], wherein said negative capacitance generated by said circuitry is dependent upon component values of said at least two resistors and said capacitor.
- 6. (Original) The integrated circuit as claimed in claim 1, wherein said circuitry is fabricated within the substrate.
 - 7. (Currently Amended) An apparatus, comprising:
 - a housing;
 - a substrate disposed within said housing;
 - at least one area of dielectric material disposed on said substrate;
 - at least one area of metal material disposed on said substrate;
- a bondpad associated with said at least one area of dielectric material and said at least one area of metal material, said bondpad being coupled to said housing; and
 - a circuitry for generating a negative capacitance, said circuitry comprising:

at least two transistors;

at least two resistors; each resistor of said at least two resistors being coupled to each of said at least two transistors; and

a capacitor coupled to a first transistor of said at least two transistors and a
first resistor of said at least two resistors; wherein said circuitry generates
generating said negative capacitance of a value to compensate for a capacitance
associated with said bondpad, said active circuitry being coupled to said bondpad.

- 8. (Original) The apparatus as claimed in claim 7, wherein said value of said negative capacitance is approximately equal in magnitude to said capacitance associated with said bondpad.
 - 9. (Canceled)

- 10. (Withdrawn) The apparatus as claimed in claim 9, wherein said at least two transistors are at least one of bipolar transistors, MOSFETS, and gallium arsenide pseudomorphic high-electron mobility transistors.
- 11. (Currently Amended) The apparatus as claimed in claim 7 [[9]], wherein said negative capacitance generated by said circuitry is dependent upon a component values of said at least two resistors and said capacitor.
- 12. (Original) The apparatus as claimed in claim 11, wherein said negative capacitance generated by said circuitry is dependent upon a ratio of a first resistor to a second resistor multiplied by a value of said capacitor.
- 13. (Original) The apparatus as claimed in claim 7, wherein said circuitry is fabricated within the substrate.
 - 14. (Currently Amended) An apparatus, comprising: a housing;
 - a substrate disposed within said housing;
 - at least one area of dielectric material disposed on said substrate;
 - at least one area of metal material disposed on said substrate;
- a bondpad associated with said at least one area of dielectric material and said at least one area of metal material, said bondpad being coupled to said housing; and
 - a circuitry for generating a negative capacitance, said circuitry comprising:
 - at least two transistors;
- at least two resistors; each resistor of said at least two resistors being coupled to each of said at least two transistors; and
- a capacitor coupled to a first transistor of said at least two transistors and a first resistor of said at least two resistors; wherein said circuitry generates generating said negative capacitance of a value to compensate for a capacitance associated with said bondpad, said active circuitry being coupled to said bondpad.

15. (Canceled)

- 16. (Withdrawn) The apparatus as claimed in claim 15, wherein said at least two transistors are at least one of bipolar transistors, MOSFETS, and gallium arsenide pseudomorphic high-electron mobility transistors.
- 17. (Currently Amended) The apparatus as claimed in claim 14 [[15]], wherein said negative capacitance generated by said circuitry is dependent upon component values of said at least two resistors and said capacitor.
- 18. (Original) The apparatus as claimed in claim 17, wherein said negative capacitance generated by said circuitry is dependent upon a ratio of a first resistor to a second resistor multiplied by a value of said capacitor.
 - 19. (Canceled)
 - 20. (Canceled)